

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Armbrust et al.

Serial No.: 09/666,325

Group Art Unit: 2811

Filed: September 21, 2000

Examiner: Kang, D.

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATIONAssistant Commissioner of Patents
Box AF
Washington, D.C. 20231SECOND AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the final Office Action mailed November 18, 2002, please amend the
application as follows.IN THE CLAIMS:

Please cancel claims 15-20 without prejudice or disclaimer.

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